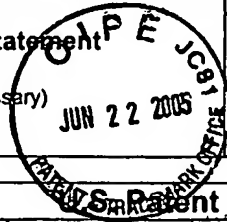


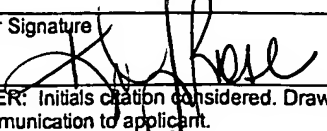
Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-024004	Application No. 10/713,275
<b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Isamu Kobori, et al.	
		Filing Date November 17, 2003	Group Art Unit 2822



U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
RR	AA	5,183,780	02/02/1993	Noguchi et al.			02/20/1991
	AB	5,341,012	08/23/1994	Misawa et al.			07/31/1992
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Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AQ	
	AR	
	AS	
	AT	

Examiner Signature 	Date Considered 9/15/05
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

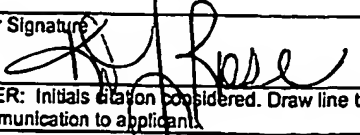
11/17/05

Substitute Form PTO-1449 (Modified)  <b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary)  (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-024004	Application No.
	Applicant Isamu Kobori et al.		
	Filing Date	Group Art Unit	

U.S. Patent Documents							
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RR	AU	6-124962	05/06/94	Japan			ABS	
	AV							

**Other Documents (include Author, Title, Date, and Place of Publication)**

Examiner Signature 	Date Considered 2/8/05 9/15/05
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Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. <b>07977-024004</b>	Application No.
<b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant <b>Isamu Kobori et al.</b>	
		Filing Date	Group Art Unit

Examiner Initial	Desig. ID	Document
<i>kl</i>	AW	Y. Fukushima, et al., "A Poly-Si TFT Process for High Speed and Low Voltage CMOS Circuits", Extended Abstracts of the 1993 International Conference on Solid State Devices and Materials, Makuhari, pp. 993-995, 1993.
	AX	

Examiner Signature <i>[Signature]</i>	Date Considered <i>2/8/05 9/15/05</i>
EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	